

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant: Pai, et al. Docket No.: TSM03-0146
Serial No.: 10/662,609 Art Unit: 2814
Filed: September 15, 2003 Examiner: Le, Thao X.
For: Dual Poly Layer and Method of Manufacture

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated August 9, 2006, which Action is made final.

Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claims 24-43.